

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Rule 53(b) Divisional Application of:

**Hideki YAMAWAKI**

Serial No.: New (Divisional Application of S.N. 10/338,647) Group Art Unit: **2812** (Expected)

Filed: Herewith

Examiner: **KENNEDY, Jennifer M.** (Expected)

For: **METHOD OF FORMING A FERROELECTRIC FILM AND FABRICATION  
PROCESS OF A SEMICONDUCTOR DEVICE HAVING A FERROELECTRIC  
FILM**

Attorney Docket No.: **021738A**

Customer Number: **38834**

**PRELIMINARY AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

January 30, 2004

Sir:

Prior to calculation of the filing fee and examination of this application, please amend the above-identified application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims that begins on page 3 of this paper.

**Remarks** begin on page 5 of this paper.